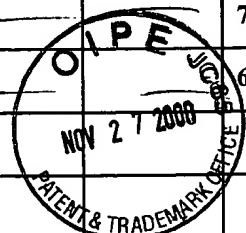


INFORMATIC DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>	Docket Number (Optional) 428291/01	Application Number 09/636,145
	Applicant(s) Etsuro Abe	
	Filing Date August 10, 2000	Group Art Unit

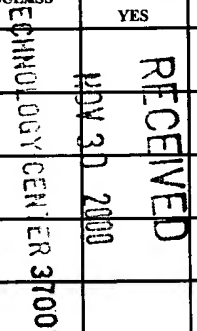
U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
ST	A	5,626,709	5/6/97	Keeny			11/15/94
ST	B	3,053,309	9/11/62	Wilson et al.			7/21/58
ST	C	5,096,407	5/17/92	Nebeling			6/8/89



FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO



OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

EXAMINER TAWFJK	DATE CONSIDERED 8/7/03
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INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>	Docket Number (Optional)	Application Number
	428291/014	New Application
	Applicant(s) Etsuro Abe	
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*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

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 08/10/00

FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
ST	A	EP 0 872 333	10/21/1998	EPO	—	—	✓	

OTHER DOCUMENTS	<i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>

EXAMINER TAWFSK	DATE CONSIDERED 8/7/03
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